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Application Number 10/816,179
Filing Date March 31, 2004
First Named Inventor Chung J. Lee

(to be used for all correspondence after initial filing)

Art Unit 1763

Examiner Name

Total Number of Pages in This Submission 4+ Attorney Docket Number DSI 302

ENCLOSURES (Check all that apply)

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| ENCLOSURES (Check all that apply) | | | | | | | | | | | |
| Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declarat Extension of Time Reques Express Abandonment Re Information Disclosure State Certified Copy of Priority Document(s) Response to Missing Part Incomplete Application Response to Miss under 37 CFR 1.5 | ing Parts | Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Addre Terminal Disclaimer Request for Refund CD, Number of CD(s) | After Allowance communication to Technology Center (TC) Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below): 1. Form PTO-1449 (one page) 2. Six "Other Documents" | | | | | | | | |
| SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT | | | | | | | | | | | |
| Firm or Individual name M. Matthews Hall, Esq. Kolisch Hartwell, P.C. | | | | | | | | | | | |
| | ather HkH | | | | | | | | | | |
| Date September 2 | 28, 2004 | | | | | | | | | | |
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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature

Date

September 28, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Date: September 28, 2004

CHUNG J. LEE, ATUL KUMAR, CHIEH CHEN and YURI PIKOVSKY

Serial No.

10/816,179

Group Art Unit 1763

Filed

March 31, 2004

For

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Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.56, 1.97, and 1.98

Applicants are submitting this Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98 to disclose to the U.S. Patent and Trademark Office the patents, publications, applications, and/or other references listed on the enclosed, completed PTO-1449 form(s). The filing of this Information Disclosure Statement should not be construed as a representation that a search has been made or as an admission that the listed references are prior art for this application. Applicants respectfully request that the listed references be expressly considered during prosecution of the application, and that the references be made of record therein and appear among the "references cited" on any patents issuing therefrom.

CONTENT OF DISCLOSURE

This Information Disclosure Statement includes (1) one page of PTO-1449 forms, and (2) a legible copy of each foreign and non-patent reference, if any, listed on the form(s). However, because this application was filed on or after July 1, 2003, no copies of U.S. patents or published U.S. patent applications are included.

TIMING OF DISCLOSURE / FEE INFORMATION

This Information Disclosure Statement is being filed, to the best of the undersigned's knowledge, either (1) before the mailing of a first Office action on the merits, or (2) before the mailing of a first Office action after the filing of a request for continued examination under 37 C.F.R. § 1.114. Therefore, in accordance with 37 C.F.R. § 1.97(b), no fee or statement under 37 C.F.R. § 1.97(e) is required.

Please contact the undersigned with any questions or comments regarding this Information Disclosure Statement.

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Respectfully submitted,

KOLISCH HARTWELL, P.C.

in. Mathew thay

M. Matthews Hall

Registration No. 43,653

Customer No. 23581

520 S.W. Yamhill Street, Suite 200

Portland, Oregon 97204

Telephone: (503) 224-6655 Facsimile: (503) 295-6679

Attorney for Assignee

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